IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Group Art Unit: 1753
Takeshi Nogami et al.) Confirmation No.: 3159
Application No. 10/775,935)
Filed: February 10, 2004)))
For: SEMICONDUCTOR MANUFACTURING APPARATUS AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICES	Examiner: Luan V. Van)))
MAIL STOP AFTER FINAL	

MAIL STOP AFTER FINAL Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO DECEMBER 20, 2006 FINAL OFFICE ACTION

Dear Sir:

This Amendment is submitted in response to the Final Office Action mailed December 20, 2006. Applicants respectfully request reconsideration of the application in view of this amendment and remarks herein.